

**A METHOD OF MANUFACTURING THIN FILM MAGNETIC HEAD****ABSTRACT OF THE DISCLOSURE**

The present invention discloses a method of manufacturing a magnetic head in which a magnetic yoke is formed on a substrate in parallel thereto by the thin film process, which comprises the steps of forming a yoke-patterned recess in a non-magnetic material layer formed on the substrate; and forming a magnetic yoke layer in such recess while forming a non-magnetic gap portion approximately normal to the substrate; wherein a split portion is provided to the gap portion so as to recess behind a level where a slide-contact plane with recording media is formed, which results in a magnetic head which can successfully prevent the noise generation over a long period, and can improve the playback efficiency.

Figure 1